MECHANICAL ENGINEERING DEPARTMENT
ME/ISYE 8773-8774

D & M MEMS Panel Discussion

Wednesday, November 5, 2008
3:15 p.m. — Refreshments before the seminar
3:30 p.m. — Graduate Seminar
Room 1130 Mechanical Engineering

ABSTRACT — Micro-Electro-Mechanical Systems (MEMS) constitute the integration of mechanical elements, sensors, actuators, and electronics on a common substrate through microfabrication technology. In this seminar, Professors Cui, Mantell, and Rajamani will discuss MEMS-related research activities in the department.

The panel will consist of faculty members in the Department of Mechanical Engineering at the University of Minnesota, Minneapolis, MN 55455

Tianhong Cui, Nelson Associate Professor, received his Ph.D. degree in Mechanical Engineering from the Chinese Academy of Sciences and his B.S. degree in Mechanical Engineering from Nanjing University of Aeronautics and Astronautics.

Susan C. Mantell, Professor, received her Ph.D and B.S. degrees in Mechanical Engineering from Stanford University. She received her M.S. in Mechanical Engineering from Northeastern University.

Rajesh Rajamani, Professor, Received his Ph.D. and M.S. degrees in Mechanical Engineering, from the University of California, Berkeley. He earned his B. Tech. degree in Mechanical Engineering from the Indian Institute of Technology, Madras.

Informal Faculty Luncheon: Wednesday, November 5, 2008, 12:00 noon. Meet in 1100 ME and walk to lunch with other faculty. Host: Prof. Sean Garrick